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FIG.1

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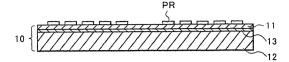


FIG.2

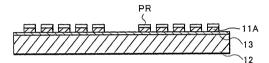


FIG.3

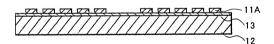
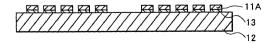


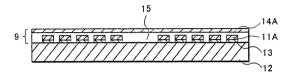
FIG.4



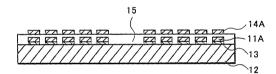
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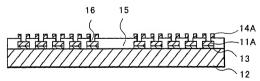
## FIG.5



### FIG.6



# FIG.7



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FIG.8

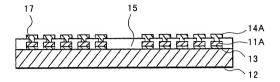


FIG.9

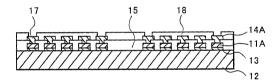
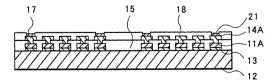


FIG.10

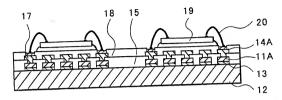


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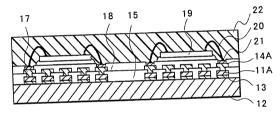
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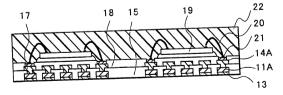
## FIG.11



## FIG.12



# FIG.13



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FIG.14



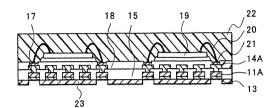


FIG.15

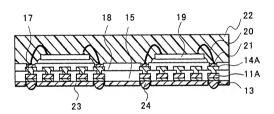
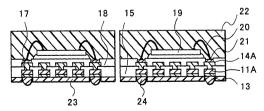
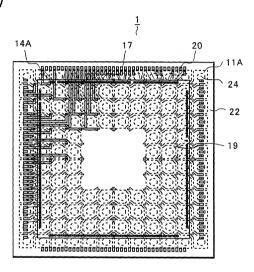


FIG.16



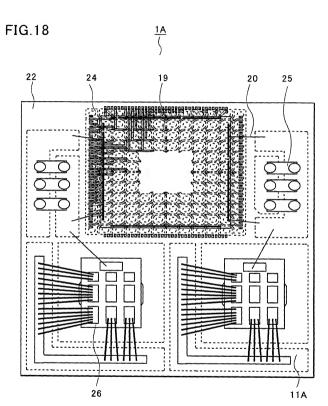
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FIG.17



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FIG.19

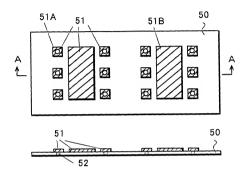


FIG.20

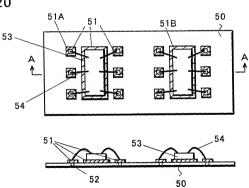


FIG.21A

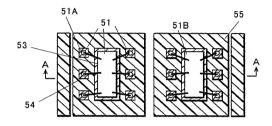


FIG.21B

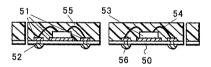
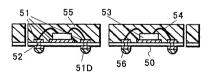


FIG.21C



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FIG.22

